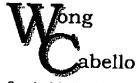
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Courselors in Intellectual Property

Wong, Cabello, Lutsch, Rutherford & Brucculeri, P.C.

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# FACSIMILE TRANSMISSION COVER SHEET

Date: Friday, September 17, 2004

To USPTO - Examiner: George Goudreau

Art Unit: 1763

Fax: 703/872-9306

From: Terril G. Lewis

Client/Matter #: 102-0072US-4

Serial No.: 09/923-058

Re: Please see the attached

Pages (including cover page): 9

# Received in the United States Patent and Trademark Office

1. Copy of Documents Previously Submitted:

- a. Request to Add Inadvertently Omitted Inventor Pursuant to 37 CFR § 1.48(a);
- b. Written Consent of Assignee to Inventorship Change Pursuant to 37 CFR § 1.48(a);
- c. Declaration; and
- d. Stamped Return Receipt Postcard.

If there is a problem with transmission, please call (832) 446-2400

### **CONFIDENTIALITY NOTICE**

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PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

David Becker et al.

Group Art Unit: 1763

Serial No.: 09/923,058

Filed: 8/6/01

Examiner: George Goudreau Examiner phone: 571-272-1434

For: METHODS FOR ENHANCING SILICON

DIOXIDE TO SILICON NITRIDE

Atty. Dkt. No.: 102-0072US-4

SELECTIVITY (as previously amended)

### COPY OF DOCUMENTS PREVIOUSLY SUBMITTED

Sir.

The following documents which were originally filed on November 21, 2003 via Express Mail are again attached herewith:

- 1. Request to Add Inadvertently Omitted Inventor Pursuant to 37 CFR § 1.48(a);
- 2. Written Consent of Assignee to Inventorship Change Pursuant to 37 CFR § 1.48(a);
- 3. Declaration.

We understand from Examiner Goudreau that these documents might have been lost at the Patent Office. Please enter these papers, and send us an Updated Filing Receipt reflecting the change in inventorship.

Respectfully submitted.

Ву

Terrif G. Lewis Reg. No. 46,065

Wong, Cabello, Lutsch,

Rutherford & Brucculeri, L.L.P.

20333 SH 249, Suite 600 Houston, TX 77070 832/446-2422 (Direct) 832/446-2424 (Facsimile)

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent

Office at 703/872-9306 on the plate below.

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WONG CABELLO

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PAGE 03

CERTIFICATE OF MAILING

37 C.F.R. 1.80

EV485192762US

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria VA, 22313-1450, on the date below:

11-21-83

Signature

**PATENT** 

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: David Becker et al.

Serial No.: 09/923,058

Filed: 8/6/01

For: METHODS FOR ENHANCING SILICON

DIOXIDE TO SILICON NITRIDE SELECTIVITY (AS PREVIOUSLY

AMENDED)

Group Art Unit: 1763

Examiner: George Goodreau

Atty. Dkt. No.: 102-0072US-4

# REQUEST TO ADD INADVERTENTLY OMITTED INVENTOR PURSUANT TO 37 C.F.R. § 1.48(a)

Commissioner for Patents P.O. Box 1450 Alexandria VA, 22313-1450

Sir:

I, Lyle Breiner, request to be added to the above-referenced patent application as an inventor pursuant to 37 C.F.R. § 1.48(a). Through no deceptive intent on the part of myself or the other inventors, my contributions to the subject matter claimed in this application were initially inadvertently overlooked upon the filing of this application. Written consent of the Assignee and provision for payment of the fee to accompany this request appears below. Also attached is a new declaration executed on behalf of all of the inventors, including myself.

Oul Breiner Date: 11/5/2003

WRITTEN CONSENT OF ASSIGNEE TO INVENTORSHIP CHANGE PUSUANT TO 37 C.F.R. § 1.48(a)

Pursuant to 37 C.F.R. 1.48(a)(5), Micron Technology, Inc., as Assignee and 100% owner of the above-referenced application, as reflected in assignments recorded at Reel/Frame 6156/0327 and 6780/0996 and/or an assignment which is attached hereto to be recorded at the USPTO. consents to the addition of Lyle Breiner as a co-inventor on this application. The undersigned has authority to execute this consent on behalf of the Assignee.

Name: Mike Lynch

Title: Chief Patent Counsel

Date: November 19, 2003

Date: //-/2-2-7

As filed by counsel for Assignee, who is authorized to act on behalf of the assignee by virtue of a power of attorney submitted herewith:

Terril G. Lewis

Reg. No. 46,065

Wong Cabello, LLP

20333 SH 249, Suite 600

Houston, TX 77070

phone: 832-446-2422 fax: 832-446-2424

Applicant authorizes the deduction of the processing fee for this Request (37 C.F.R. § 1.48(a)(4); 37 C.F.R. § 1.17(i)), and the deduction of any other necessary fees, from Deposit Account 501922, referencing 102-0072US-4.

# RECEIVED IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MICRON TECHNOLOGY Serial No. 09/923,058

102-0072US-4

Response to Office Action Dated 9/25/2003 and Terminal Disclaimer, Request to Add Inadvertently Omitted Inventor Pursuant to 37 CFR 1.48; Declaration;

Election Under 37 CFR §§ 3.71 and 3.73 and Power of Attorney; PTO-1595, Assignment

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· Mailed: 11/21/2003

